



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE PATENT APPLICATION OF: Ockenfuss et al

Serial No: 10/004,142

Group: 2872

Filed: 11/14/2001

Examiner: Arnel Lavarias

GT-2872  
#6/Election/A  
D. EVANS  
321.03

DATE: February 27, 2003

ELECTION OF SPECIES AND PRELIMINARY AMENDMENT

The Commissioner of Patents and Trademarks  
Washington, D.C. 20231  
U.S.A.

RECEIVED  
MAR - 7 2003  
TC 2800 MAIL ROOM

Dear Sir:

In Response to the Office communication mailed February 11, 2003,  
please consider the following remarks and amend the application as follows:

IN THE CLAIMS

1. (amended) A process for making a multilayer interference filter assembly comprising the steps of:
- a) providing a first substrate,
  - b) depositing a removable multilayer interference filter over said first substrate,
  - c) removing the multilayer interference filter from the first substrate to form a free standing filter;
  - d) attaching the free standing filter to a second substrate having a coefficient of thermal expansion enabling the second substrate to apply a stress to the free standing filter for at least partially compensating for a shift in center wavelength over an operating temperature range.